



Thematic Network on Silicon on Insulator Technology, Devices and Circuits.
[IST-1-506653-CA]

EUROSOI "Who is Who" Guide

Name of the organisation	
<i>Organization Legal name:</i>	TRACIT TECHNOLOGIES SA,
<i>Organization short name:</i>	
<i>Internet homepage:</i>	www.tracit-tech.com

Contact person			
<i>Name:</i>	<i>ASPAR</i>	<i>Title:</i>	<i>Dr</i>
<i>First name:</i>	<i>Bernard</i>	<i>Sex:</i>	<i>M</i>
<i>Phone:</i>	<i>33(0)438784698</i>	<i>E-mail:</i>	<i>Bernard.aspar@tracit-tech.com</i>
<i>Postal Address</i>	<i>Zone Astec, 15 rue des Martyrs, 38054 Grenoble Cédex 9 - France</i>		

Other Senior Researchers: (up to 10 names, please include e-mail address)

Dr Crystelle LAGAHE-BLANCHARD, chrystelle.lagahe@tracit-tech.com

Dr Thierry BARGE, Thierry.barge@tracit-tech.com

Dr Michael FIEVRE, michael.fievre@tracit-tech.com

Dr Gwenaëlle RUMEN, gwenaëlle.rumen@tracit-tech.com

Experience and expertise fields: (50 words)

Tracit Technologies is a spin-off from the CEA-LETI, specialized in thin film transfer by molecular adhesion and mechanical and/or chemical thinning.

TRACIT Technologies is specialized in BSOI wafers, customized BSOI wafers and D-BSOI™ wafers, and in the field of transfer of thin circuits onto different supports .

Facilities and Equipment:

Clean-rooms with all the equipments to process BSOI wafers, to perform Direct Wafer Bonding (cleaning – annealing), chemical mechanical polishing, mechanical & chemical thinning.

Three last international research projects:

- PICMOS (European Project 6th PCRD)